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IPW

520.36911CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al  
Serial No.: 09/249,292  
Filed: February 12, 1999  
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR  
Group: 1763  
Examiner: A. Olsen

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 14, 2004

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed March 19, 2004. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (520.36911CX2).

Respectfully submitted,

Melvin Kraus  
Registration No. 22,466  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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(703) 312-6600